

U.S. PTO
JC675 09/722485
11/28/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masaki NARUSHIMA

SERIAL NO: NEW APPLICATION

GAU:

FILED: Herewith

EXAMINER:

FOR: CERAMIC HEATER SYSTEM AND SUBSTRATE PROCESSING APPARATUS HAVING THE SAME INSTALLED
THEREIN

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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HAVING THE SAME INSTALLED THEREIN



STATEMENT OF RELEVANCY

Reference AO (7-272834) on Form PTO-1449:

This reference discloses a ceramic heater having a technical structure in which a flow path is provided along the heat generator between the heating surface of the heater and the heat generator, and a method of manufacturing such a heater.

Reference AP (9-219439) on Form PTO-1449:

This reference discloses a substrate processing device having a technical structure in which a fluid is supplied to fill the groove made in the surface of the placement table through a fluid introduction path communicating to the groove, so as to control the temperature of the placement table at low.

Reference AQ (8-17747) on Form PTO-1449:

This reference discloses a processing device as well as processing method capable of increasing the deposition rate of its process gas material without increasing the consuming amount of the process gas while processing an object to be processed under a certain processing gas atmosphere.

Reference AR (63-276225) on Form PTO-1449:

This reference discloses an ashing-processing device for ashing-processing a photoresist film while supplying ozone thereto.